Form PTO-1595 (Rev. 09/04) 06 - 2 OMB No. 0651-0027 (exp. 6/30/2005)	3 - 2005 U.S. DEPARTMENT OF COMME
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To the Director of the U.S. Patent and Trademark Office: Ple	pase record the attached documents or the new address(es) below.
1. Name of conveying party(ies)/Execution Date(s)	
1. Masato IYOKI	Name: SII NanoTechnology Inc.
2. Akihiko HIDAKA 3. Kazutoshi WATANABE	Internal Address:
Execution Date(s) FEBRUARY 22, 2005  Additional name(s) of conveying party(ies) attached? Yes \( \begin{align*} \text{Yes} \end{align*}	Street Address: 8, Nakase 1-chome, Mihama-ku
3. Nature of conveyance:	<u>Chiba-shi</u>
✓ Assignment Merger	City: Chiba
Security Agreement Change of Name	
Government Interest Assignment	State:
Executive Order 9424, Confirmatory License	Country: JAPAN Zip: 261-8507
Other	Additional name(s) & address(es) attached? Yes
4. Application or patent number(s):	is document is being filed together with a new applicati
A. Patent Application No.(s)	B. Patent No.(s)
11/045,916	PR
	attached? Yes No
Additional numbers	attached? Yes No
5. Name and address to whom correspondence concerning document should be mailed:	6. Total number of applications and patents:
Name:Bruce L. Adams	<del></del>
Internal Address:	7. Total fee (37 CFR 1.21(h) & 3.41) \$ 40.00
internal Address.	Authorized to be charged to deposit account
Street Address: Adams & Wilks	ANY DEFICIENCY IN ENCLOSED FEE
50 Broadway - 31st Floor	None required (government interest not affecting t
City: New York	8. Payment Information
State: New York Zip: 10004	a. Credit Card Last 4 Numbers
Phone Number: (212) 809-3700	Expiration Date
Fax Number: (212) 809-3704	b. Deposit Account Number 01-0268
Email Address:	Authorized User Name Bruce L. Adams
9. Signature:	
D5 DBYRNE 00000275 11045916 Signatur	JUNE 17, 2005  Date
21 Bruce L. Adams	Total number of pages including cover 2
Name of Person Signing	sheet, attachments, and documents:

Documents to be recorded (including cover sheet) should be faxed to (703) 306-5995, or mailed to:
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## MAILING CERTIFICATE ON REVERSE SIDE OF PAGE

PATENT REEL: 016703 FRAME: 0654

## **ASSIGNMENT**

WHEREAS, we, Masato IYOKI, Akihiko HIDAKA and Kazutoshi WATANABE residing at c/o SII NanoTechnology Inc., 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan have invented new and useful improvements in FINE-ADJUSTMENT MECHANISM FOR SCANNING PROBE MICROSCOPY for which we have prepared an application for Letters Patent of the United States of America; AND WHEREAS, SII NanoTechnology Inc., located and doing business at 8, Nakase 1-chome. Mihama-ku, Chiba-shi, Chiba, Japan, is desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor; NOW, THEREFORE, be it known by all whom it may concern, that for and in consideration of Ten Dollars (\$10.00) and other good and valuable consideration to us in hand paid, the receipt of which is hereby acknowledged, we have assigned, sold and transferred and by these presents do hereby assign, sell and transfer unto the said SII NanoTechnology Inc. for the territory of the United States of America, our entire right, title and interest in and to the said invention, and in and to the said application, prepared and executed by us on February 22, 2005, filed January 28, 2005, Serial No. 11/045,916, preparatory to obtaining Letters Patent thereon and in and to any and all divisions, reissues and continuations thereof, and in and to any Letters Patent that may be granted thereon; said invention, application and Letters Patent to be held and enjoyed by the said SII NanoTechnology Inc., its legal representatives and assigns, as fully and entirely as the same would have been held by us had this assignment, sale and transfer not been made. AND, we hereby covenant and agree that we will at any time upon the request and at the expense of said assignee execute and deliver any and all papers and do all lawful acts that may be necessary or desirable to perfect the title to said invention and to obtain Letters Patent therefor, and we hereby authorize and request the Honorable Commissioner of Patents and Trademarks to issue the said Letters Patent to the said SII NanoTechnology Inc. in accordance with this assignment. Executed this 22nd day of February, 2005 at \_\_\_\_\_ Witness: Masato byoki (L.S.) Kazutoshi Watanalo (L.S.)

RECORDED: 06/17/2005

PATENT REEL: 016703 FRAME: 0655